RECEIVED CENTRAL FAX CENTER

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE APR 1 4 2005 (Atty. Docket No. 100176)

First Inventor: Roland K. SEVILLA

Application./Serial No.:

10/601,601

Filing Date:

23-Jun-03

Title: POLISHING PAD FOR

ELECTROCHEMICAL-

MECHANICAL POLISHING

Examiner:

M. Rachuba

Group Art Unit:

3723

### CERTIFICATE OF FACSIMILE TRANSMISSION

I Maricjose Monsalve, hereby certify that this Penirion for Withdrawal of Abandonment is being faxed to:

(703) 872-9306 Mail Stop Petition Commissioner for Patents P.O. Box 1450 Alexandria. VA, 22313-1450

m 104 Apr 2005

Senature

### PETITION UNDER 37 C.F.R. §1.181 TO WITHDRAW THE HOLDING OF ABANDONMENT

The petitioner respectfully requests that the abandonment set forth in the notice mailed by the office on March 3, 2005 be withdrawn.

In support of this petition the following are submitted:

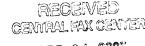
- (A) A true copy of the Notice of Abandonment;
- (B) A true copy of the Applicant's Response and Election filed on August 4, 2004;
- (C) A true copy of the facsimile transmittal confirmation

No fee is required for this petition. The applicant respectfully requests that the active status of this application be acknowledged and the holding of abandonment be withdrawn.

Respectfully submitted,

Steven Weseman (Reg. No. 41,372)

Legal Department
Cabot Microelectronics Corporation
870 North Commons Drive
Aurora, Illinois 60504
Tel. (630) 375-5465







### United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.uspio.gov

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO	
10/601,601	06/23/2003	Roland K. Sevilla	100176X219814	1503	
	7590 03/03	2005	EXAM	INTER	
29050 STEVEN D	WESEMAN, AS	RACHUBA, MAURINA T			
CABOT MIC	CROELECTRONIC	ART UNIT	PAPER NUMBER		
870 NORTH AURORA,	COMMONS DRIV	E.	CABOT MICROELECTRONICS		
110,141-1			DATE MAHED: 03/03/200	)5	
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			law department	<b>\$</b>	

DOCKETEN

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)
_		SEVILLA, ROLAND K.
Notice of Abandonment	10/601,601 Examiner	Art Unit
1101100 0.110111-1-1111		3723
	M Rachuba	
- The MAILING DATE of this communication app	pears on the cover sheet with the t	
This application is abandoned in view of:		
<ol> <li>Applicant's failure to timely file a proper reply to the Office         <ul> <li>(a)  A reply was received on (with a Certificate of period for reply (including a total extension of time of</li> </ul> </li> </ol>	mosth(e)) which excited on	), which is after the expiration of the
us to a second continuous received on that it does	s vot coustitute a bioher rebit priper .	0) 011211114 (-)
(A proposed reply was received on(A proper reply under 37 CFR 1.113 to a final rejectic application in condition for allowance; (2) a timely file Continued Examination (RCE) in compliance with 37	CFR 1.114).	(-)
(c) A reply was received on — but it does not constitute final rejection. See 37 CFR 1.85(a) and 1.111. (See	itute-a-proper reply, or a bona-tide at e explanation in box 7 below).	fembratarbroder rebit/ roung non-
(d) No reply has been received.		
<ol> <li>Applicant's failure to timely pay the required issue fee a from the mailing date of the Notice of Allowance (PTOL-</li> </ol>		
<ul> <li>(a) The issue fee and publication fee, if applicable, we, which is after the expiration of the statutory Allowance (PTOL-85).</li> </ul>	as received on (with a Cermi period for payment of the issue fee (	and publication fee) set in the Notice of
(b) ☐ The submitted fee of \$ is insufficient. A balan	nce of \$ is due.	
The issue fee required by 37 CFR 1.18 is \$	. The publication fee, if required by 3	7 CFR 1.10(0), is 9
(c) The issue fee and publication fee, if applicable, has		
3. Applicant's failure to timely file corrected drawings as re Allowability (PTO-37).		
Allowability (P1O-37).  (a) ☐ Proposed corrected drawings were received on  after the expiration of the period for reply.	(with a Certificate of Mailing or Tr	ansmission dated), which is
(b) ☐ No corrected drawings have been received.	•	
<ol> <li>The letter of express abandonment which is signed by the applicants.</li> </ol>		
5. The letter of express abandonment which is signed by 1.34(a)) upon the filing of a continuing application.		
6. ☐ The decision by the Board of Patent Appeals and Inter- of the decision has expired and there are no allowed d	ference rendered on and beca laims.	ause the period for seeking court review
7. The reason(s) below:		
Petitions to revive under 37 CFR 1.137(a) or (b), or requests to with	ndraw the holding of abandonment under	M Rachuba Primary Examiner Art Unit: 3723 37 CFR 1.181, should be promptly filed to

Comparable to FORM PTO-1083

PATENT No. 100176

Attorney Docket No. 100176 Date: August 4, 2004

In re Application of, Roland K. SEVILLA

Application No.

10/601,601 23-Jun-03

Filed: For:

POLISHING PAD FOR ELECTROCHEMICAL-MECHANICAL POLISHING

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to an office action in the subject application.

☐ Small entity status is claimed for this application under 37 CFR 1.27.

Petition for an extension of time for the period stated below, as well as for any additional period necessary to render the present submission timely. Please charge Deposit Account No. 501599 for the appropriate petition fee.

☐ Other.

Please charge Deposit Account No. 501599 in the total amount indicated below.

			One month		SMALL ENTITY \$ 0.00		OTHER THAN A SMALL ENTITY \$0.00 (\$ 0.00) \$0.00	
TIME EXTENSION PETITION FEE								
	subtract time extension fee previously pald		none		(\$	0.00)		
	<del></del>							
CLAIM FEE	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	EXTRA CLAIMS PRESENT	SMALL ENTITY RATE	ADDIT. CLAIM FEE	LARGE ENTITY RATE	ADDIT. CLAIM FEE
TOTAL	21	Minus	26	0	9	\$	18	S
INDEPENDENT	1	Minus	1	0	43	\$	86	\$
☐ FIRST PRE	SENTATION OF MUL	TIPLE CLAIM			145	\$	290	\$
TOTAL AMOUNT	TO BE CHARG	ED TO DEF	POSIT ACCOUNT	· · · · ·	TOTAL	s	TOTAL	\$0

Comparable to FORM PTO-1083

PATENT Attorney Docket No. 100176 Date: August 4, 2004

In re Application of: Roland K. SEVILLA

Application No.

10/601,601

Filed: For:

23-Jun-03 POLISHING PAD FOR ELECTROCHEMICAL-MECHANICAL POLISHING

CENTRAL FAX CENTER

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 APR 04 2005

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☐ Other:

Please charge Deposit Account No. 501599 in the total amount indicated below.

					SMALL ENTITY		OTHER THAN A SMALL ENTITY	
TIME EXTENSION PETITION FEE		<u>-</u>	One month		\$	0.00	\$0	.00
	subtract time extension fee previously paid		none		(\$ 0.00)		(\$ 0.00)	
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CLAIM FEE	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	EXTRA CLAIMS PRESENT	SMALL ENTITY RATE	ADDIT. CLAIM FEE	LARGE ENTITY RATE	ADDIT. CLAIM FEE
TOTAL	21	MINUS	26	0	9	\$	18	\$
INDEPENDENT	1	Minus	1	0	43	\$	86	\$
	SENTATION OF MUL	TIPLE CLAIM			145	\$	290	\$
					_			<del> </del>
			POSIT ACCOUNT		TOTAL	\$	TOTAL	\$0

☑ The Commissioner is hereby authorized to charge any deficiencles in the following fees associated with this communication or credit any overpayment to Deposit Account No. 501599.

✓ Any filing fees under 37 CFR 1.16 for the presentation of extra claims.
 ✓ Any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

Steven D. Weseman, Reg. No. 41,372

Legal Department Cabot Microelectronics Corporation 870 North Commons Drive Aurora, IL, 60504 (630)

375-5465

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE (Atty. Docket No. 100176)

RECEIVED CENTRAL FAX CENTER

First Inventor: Roland K. SEVILLA

Serial No.:

10/601,601

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23-Jun-03

Examiner:

Maurina T. Rachuba

Art Unit:

3723

Title: POLISHING PAD FOR

ELECTROCHEMICAL-MECHANICAL

**POLISHING** 

Certificate of Facsimile Transmission

I. Mariejose Monsalve, hereby certify that this paper and enclosure(s), if any, are hereby being transmitted to the USPTO's Centralized Facsimile Number for Official Patent Application Related Correspondence, facsimile No. (703) 872-9306 on

100 11 0

(Sender's signatu

Commissioner for Patents P.O. Box 1450 Alexandria, VA, 22313-1450

### RESPONSE AND ELECTION

In response to the Office Action of July 28, 2004, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.

8/4/2004 Response and Election USSN 10/601,601 Page 2 of 5

### CLAIM AMENDMENTS

- 1. (Original) A polishing pad comprising a body having (a) a top surface comprising a first set of grooves with a first depth and first width and (b) a bottom surface comprising a second set of grooves with a second depth and second width, wherein the first set of grooves and second set of grooves are interconnected and are oriented such that they are not aligned.
- (Original) The polishing pad of claim 1, wherein the first and second sets of
  grooves have a cross-sectional shape selected from the group consisting of lines, curves,
  circles, ovals, squares, rectangles, triangles, diamonds, and combinations thereof.
- 3. (Original) The polishing pad of claim 2, wherein the grooves are linear grooves.
- (Original) The polishing pad of claim 3, wherein the first and second sets of grooves are non-parallel.
- 5. (Original) The polishing pad of claim 1, wherein the polishing pad has a void volume of about 30% or more.
- 6. (Original) The polishing pad of claim 5, wherein the polishing pad has a void volume of about 70% or more.
- 7. (Original) The polishing pad of claim 1, wherein the first set of grooves is rotated by an angle of about 10° to about 90° relative to the second set of grooves.
  - 8. (Original) The polishing pad of claim 7, wherein the angle is about 90°.
- 9. (Original) The polishing pad of claim 1, wherein a first depth of the first set of grooves and a second depth of the second set of grooves combine to have a total groove depth that is about equal to or greater than the thickness of the polishing pad.

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- 10. (Original) The polishing pad of claim 9, wherein the first set of grooves and second set of grooves are interconnected by primary channels that are oriented perpendicular to the top surface of the polishing pad.
- (Original) The polishing pad of claim 10, further comprising a plurality of secondary channels extending through the thickness of the polishing pad.
- 12. (Original) The polishing pad of claim 1, wherein a first groove depth of the first set of grooves and a second groove depth of the second set of grooves combine to have a total groove depth that is less than the thickness of the polishing pad.
- 13. (Original) The polishing pad of claim 12, wherein the first and second sets of grooves are interconnected by a plurality of secondary channels extending through the thickness of the polishing pad.
- 14. (Original) The polishing pad of claim 1, wherein the first set of grooves, the second set of grooves, or a combination thereof have an average groove width of about 0.1 mm to about 2 mm.
- 15. (Original) The polishing pad of claim 1, wherein the first groove width and the second groove width increase from one side of the polishing pad to the other side of the polishing pad.
- 16. (Original) The polishing pad of claim 1, wherein the body comprises a polymer resin selected from the group consisting of thermoplastic elastomers, thermoplastic polyurethanes, thermoplastic polyolefins, polycarbonates, polyvinylalcohols, nylons, elastomeric rubbers, elastomeric polyethylenes, polytetrafluoroethylenes, polyethylenes, polyethylenes, polyarylenes, polyarylenes, polyarylenes, polyarylenes, polystyrenes, polymethylmethacrylates, copolymers thereof, and mixtures thereof.
- 17. (Original) The polishing pad of claim 16, wherein the polymer resin is a thermoplastic polyurethane resin.

8/4/2004 Response and Election USSN 10/601,601 Page 4 of 5

- 18. (Original) The polishing pad of claim 1, wherein the body of the polishing pad further comprises abrasive particles.
- 19. (Original) The polishing pad of claim 1, wherein the polishing pad is conductive.
- 20. (Original) The polishing pad of claim 19, wherein the body of the polishing pad further comprises conductive elements.
- 21. (Original) The polishing pad of claim 19, wherein the body of the polishing pad further comprises a conductive polymer.

22-26. (Canceled)

8/4/2004 Response and Election USSN 10/601,601 Page 5 of 5

#### REMARKS

The Examiner has determined that the present application as filed contains claims directed to at least two groups of distinct inventions. In particular, the groups, as determined by the Examiner, are:

- Claims 1-21, drawn to a polishing pad, classified in class 451, subclass 526;
- II. Claims 22-26, drawn to a method of polishing, classified in class 438, subclass 692.

Applicants hereby elect to pursue claims in Group I (claims 1-21) in the present application. Accordingly, non-elected claims 22-26 are canceled without prejudice, and may be pursued in a divisional application. This election is made without traverse. An early action on the merits is solicited.

Respectfully submitted,

y: XIV VIV 1492 Steven D. Weseman

Reg. No. 41,372

Attorney for Applicant(s)